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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10002177	FILING DATE 12/05/2001	CLASS 425	SUBCLASS 730	GAU 1723	EXAMINER Kackar
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**CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:

JAPAN 2000-373278 12/07/2000

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO
35 USC 119 conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no	Q67579
Verified and Acknowledged Examiners's initials		
TITLE : Film-forming device with a substrate rotating mechanism		

U S DEPT OF COMM /PAT & TM-PTO-436L Rev 12-94

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	Total Claims
			Print Claim for O.G
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Primary Examiner	Sheets Drwg. Figs.Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner
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